

Docket No.: 4425-320

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Chien-Hsin LAI *et al.*

U.S. Patent Application No. 10/659,258

Filed: September 11, 2003

:
: EXPEDITED PROCEDURE
: Response under 37 CFR 1.116
:
: Confirmation No. 3535
: Group Art Unit: 1763
: Examiner: Karla A Moore

**For: PLASMA APPARATUS AND METHOD CAPABLE OF ADAPTIVE
IMPEDANCE MATCHING**

Commissioner for Patents
P. O. Box 1450
Alexandria VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action of May 18, 2006 please amend the above-identified application as follows:

PLEASE ENTER 9/7/06 